

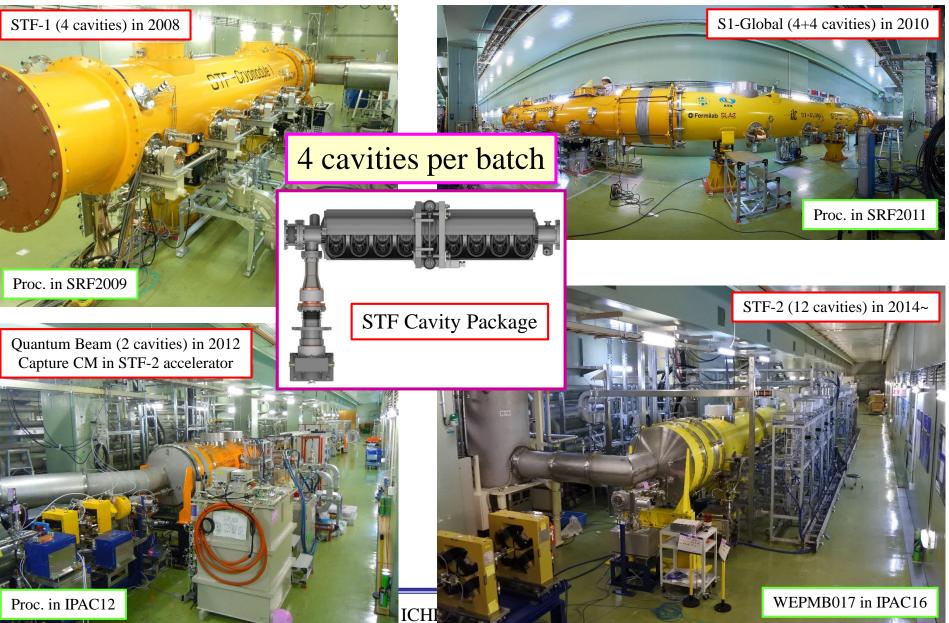
# STF-2 Cryomodule Performance and New Input Coupler R&D for ILC

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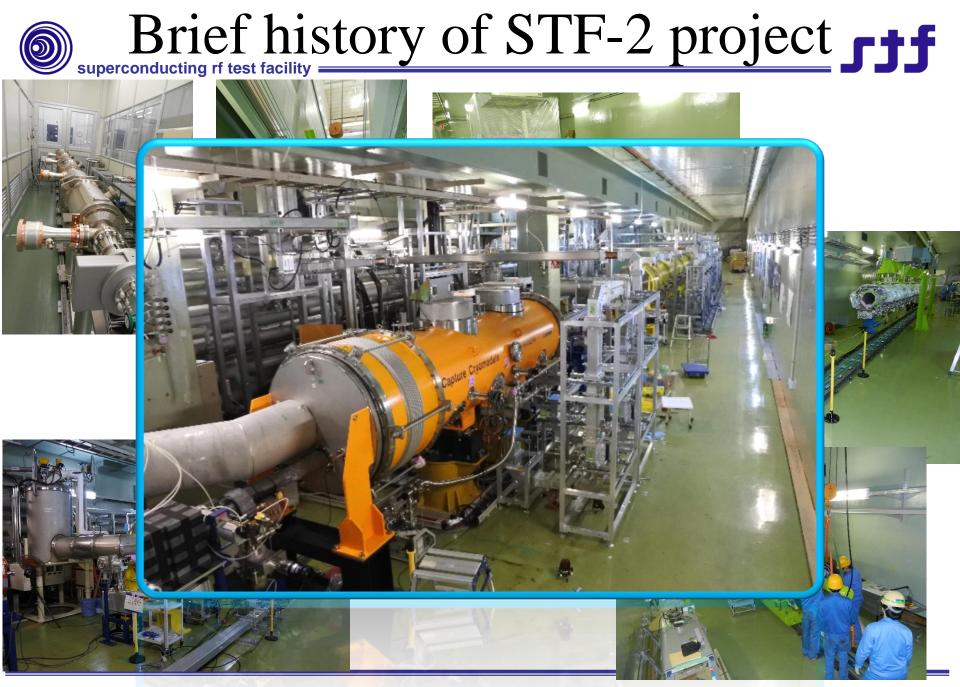




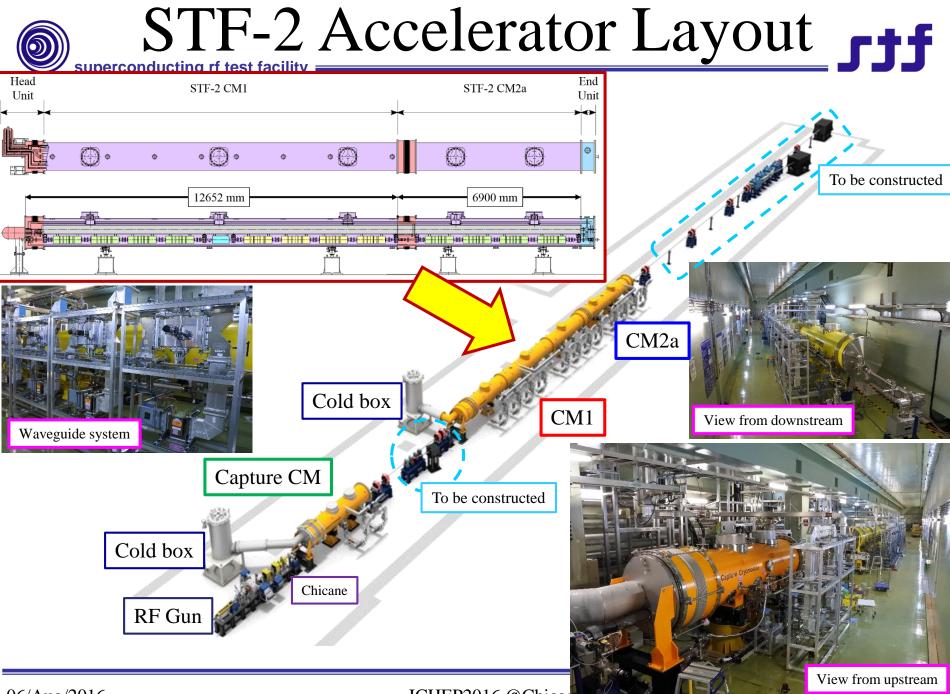
### STF-2 Cryomodule Performance

1<sup>st</sup> topic

Date	Content			
2011 ~ 2013	V.T. for 12 cavities			
Jun/2013	Cleaning up STF tunnel			
Jul/2013 ~ Apr/2014	Cavity string assembly (three times)			
Oct/2013 ~ Jan/2014	Module assembly (CM1/CM2a)			
Jul/2014	Complete certification for High pressure Gas Code			
Oct/2014 ~ Dec/2014	1 <sup>st</sup> cool-down / low power test			
Apr/2015 ~ Jul/2015	5MW Klystron / Single waveguide system completed			
Jul/2015 ~ Sep/2015	Coupler conditioning at room temperature			
Oct/2015 ~ Dec/2015	2 <sup>nd</sup> cool-down / high power test			
Jan/2016 ~ Jul/2016	Multi-beam Klystron & Waveguide system completed			
Jul/2016 ~ Sep/2016	Coupler conditioning at room temperature			
Sep/2016 ~ Dec/2016	$3^{rd}$ cool-down / $Q_0$ measurement & LLRF study			
2017 ~ 2018	Beam operation will start?			



06/Aug/2016



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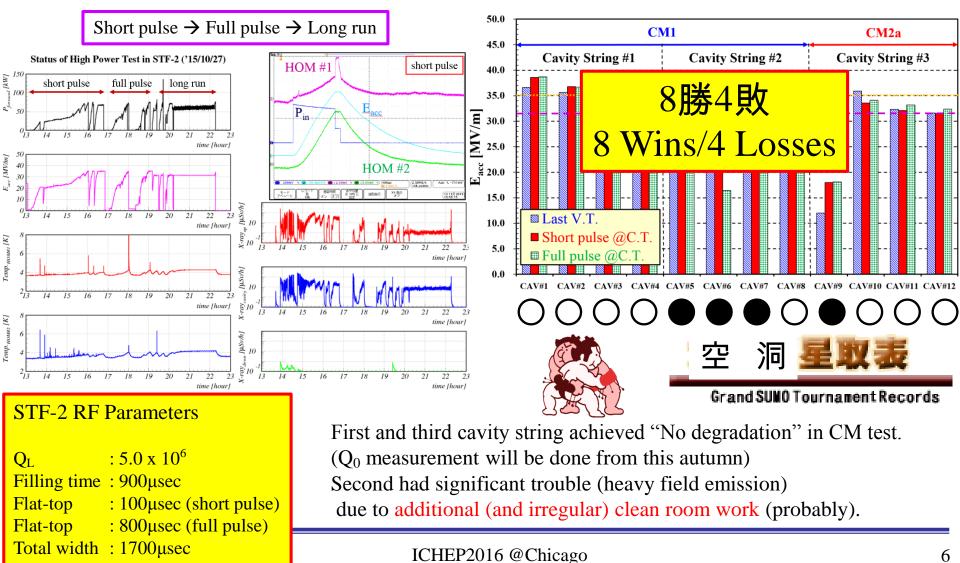
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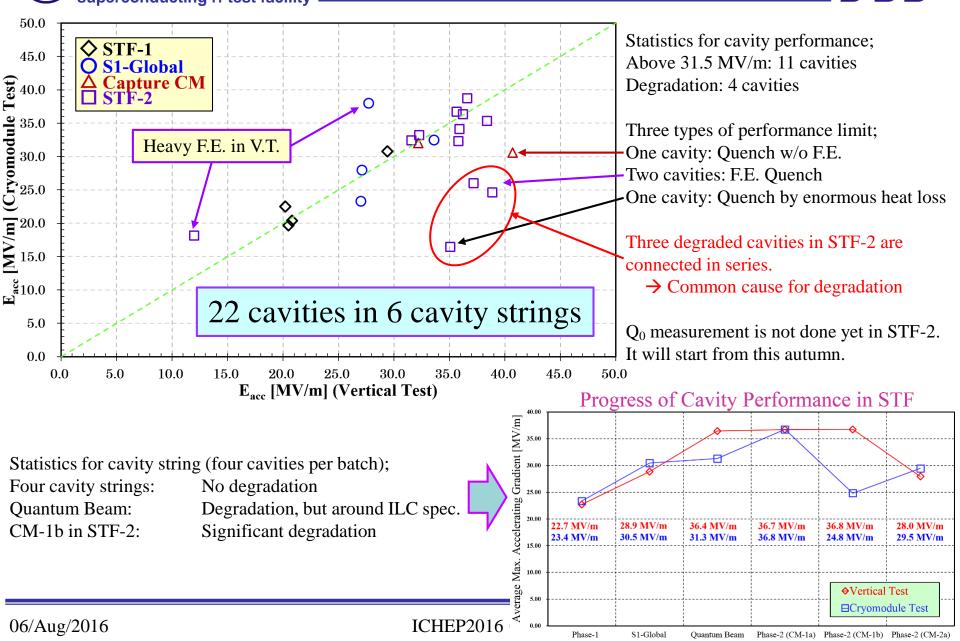
# Performance for STF-2 Cryomodyle

RF conditioning was done very carefully as monitoring

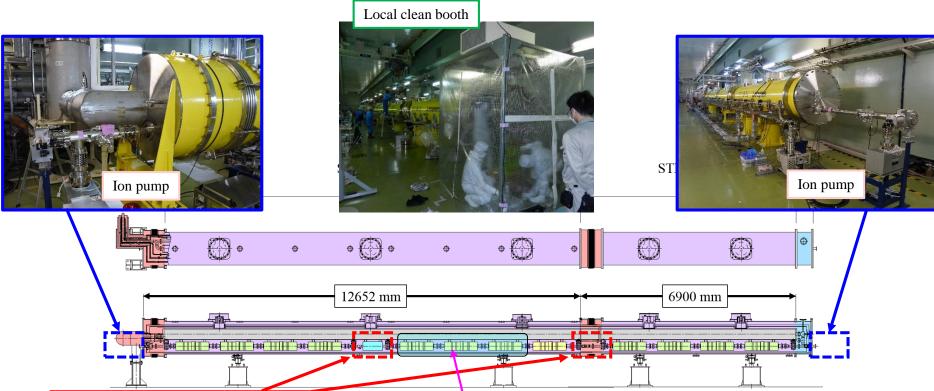
heating at HOM couplers, unusual RF output from HOM couplers, and radiation level.

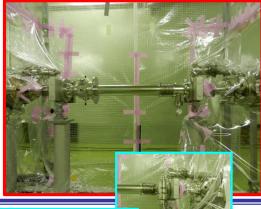


### Performance Degradation



# avity string/Beam pipe connection in Tunnel





#### Three degraded cavities in series

- $\checkmark$  Use of simply local clean booth
  - $\checkmark$  Local clean booth was used for four beampipe connection parts
- $\checkmark$  Exchange of metal valve near cavity string #2
  - $\checkmark$  Metal valve was a little bit bigger, disturbed thermal shield attachment
- ✓ Extra Argon gas purging at gate valve opened
  - ✓ Usually, when gate valve opens, both sides should be under vacuum but, we had to do Argon gas purging for the both sides due to complicated process of cryomodule assembly

# Improvement of clean room items

superconducting rf test facility



### Many experiences in EU-XFEL @DESY



- High quality local clean booth
- Slow pumping system
- High quality particle counter
- Ultrasonic rinsing for ion pump  $\succ$

Will be introduced in 2017(?)

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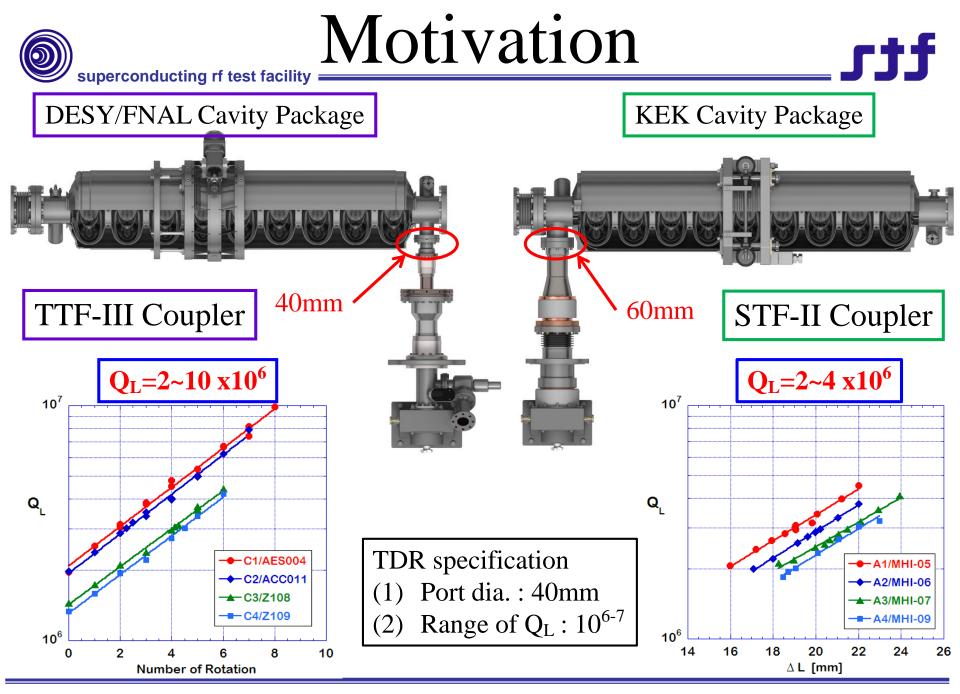




### New Input Coupler R&D

2<sup>nd</sup> topic

Date	Content			
Nov/2013	Recommendation for plug-compatible design from LCC			
Feb/2014	Completion of mechanical design			
Jun/2014	Completion of RF design by simulation			
Nov/2014	Completion of Test Coupler Fabrication			
Mar/2015	Incoming inspection in KEK			
Dec/2015	Low power test at test bench			
Feb/2016	High power test at test bench			



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RFDesign & Fabrication

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Coupler (TOSHIBA)	Product No.	Serial No.	Ceramic company	Ceramic color	Ceramic coating
Warm #1, #2 (normal)	E42130	14L001 14L002	NGK/NTK	White	TiN
Cold #1, #2 (normal)	E42130	14L001 14L002	NGK/NTK	White	TiN
Cold #3, #4 (new)	E42130	14L003 14L004	KYOCERA	Gray	free

Warm part is common

View point of plug-compatibility

 Longer tapered pipe for 40mm port
 Longer bellows for wider range of QL

 View point of lower cost study

 Coating-free ceramic
 Coating process is dominant in cost



# superconducting rf test facility

#### Head of inner conductor for Cold part #1

Many blisters at head of inner conductor

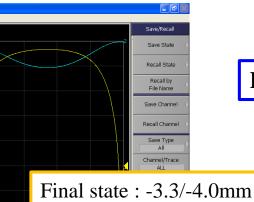


TERW 10 kH

T 1MΩ 20dB R 1MΩ 20dB

timelus 4 Mkr/Amalusis

Center 1.3 GH



Snan 200 MHz Cox L

Final state : -3.3/-4.0mm **S**<sub>11</sub> : -47.57 dB @1.3GHz **S**<sub>21</sub> : -0.126 dB @1.3GHz

Low power test

Ultrapure water rinsing

Assembly in clean room

# Superconducting rf test facility Coupler Test Stand Uptrem Wam Vac

Arc #2

Buffer Amp.

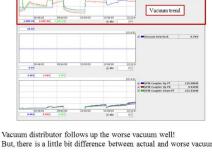
Vacuum Distributor

P<sub>forward</sub>

- ➢ Warm part is common
- Two kinds of cold parts (TiN coating/free)

Pbackward

- ➢ Goal: 1200 kW for <500µs</p>
- $\blacktriangleright \quad \text{Goal: 800 kW for >500} \mu \text{s}$
- Monitor: Vacuum, Electron, Arc, VSWR
- Devices: Auto-conditioning & Vacuum distributor modules



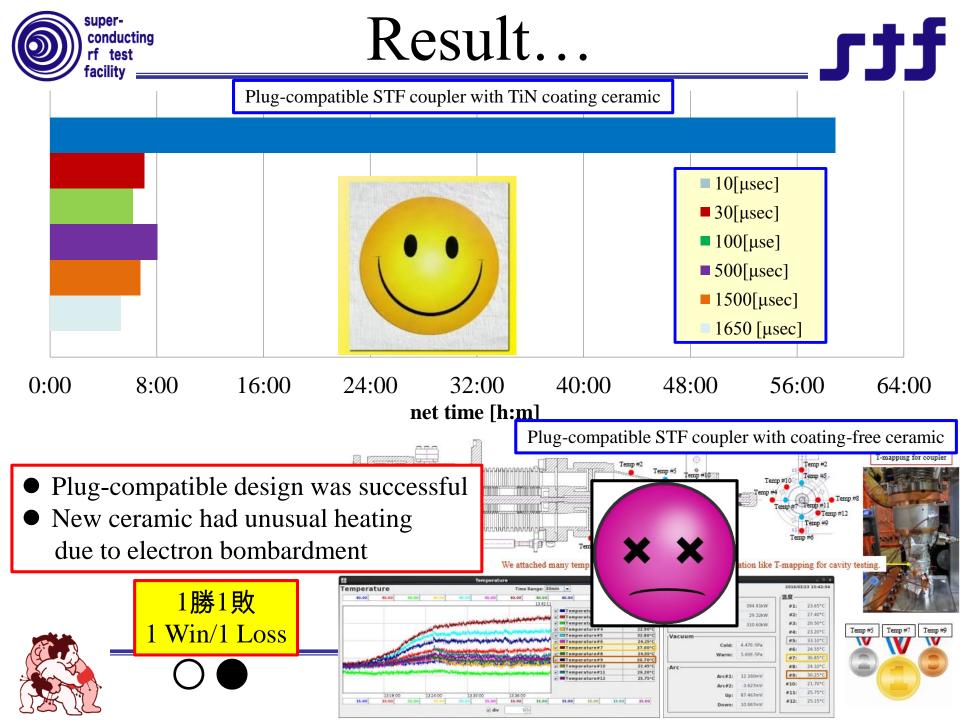
Good collaboration between CERN and KEK (Thank you very much)

Arc #1

Vac I/L module

ariable Buffer Amp.

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# Summary & Future plan JJ

- ✓ STF-2 cryomodule test have been done twice
  - ✓ Eight cavities achieved above 31.5 MV/m as ILC spec.
  - $\checkmark$  Three cavities had significant degradation
  - ✓ One cavity already had heavy F.E. in V.T.
- ✓ New coupler design for plug-compatibility was successful
  - $\checkmark$  Longer bellows and narrow coaxial pipe were no problem
- $\checkmark$  New ceramic had some problem, and need to improve somethings
  - ✓ Unusual heating at tapered pipe was generated by electron bombardment
- ✓  $3^{rd}$  STF-2 cryomodule test will be done from this autumn
  - ✓ Measurement for  $Q_0$  and Lorenz Force Detuning, and LLRF study
  - ✓ Eight cavities operation, additionally injector cryomodule (two cavities)
- ✓ New clean room items will be introduced for beampipe connection ✓ High quality local clean booth, and particle counter, and slow pumping unit
  - ✓ High quality local clean booth, and particle counter, and slow pumping unit
- ✓ More inspection for new ceramic will be done with some vendors
  - ✓ Secondary electron emission coefficient for new ceramic will be measured





### Thank you very much for your attention





# **Back-up slides**

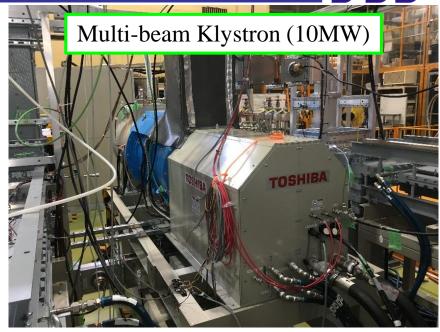
# dditional items for beam commissioning



Waveguide system for eight cavities

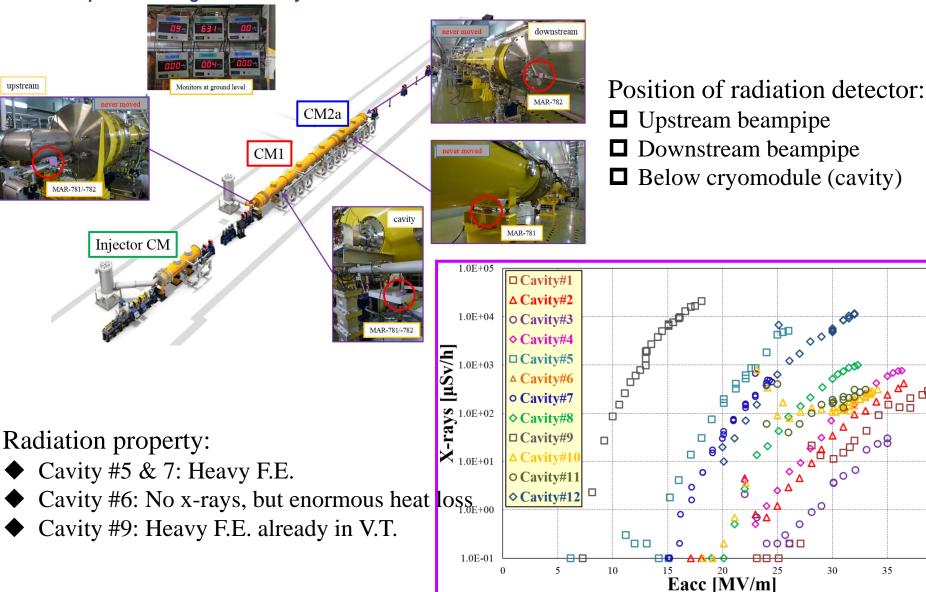


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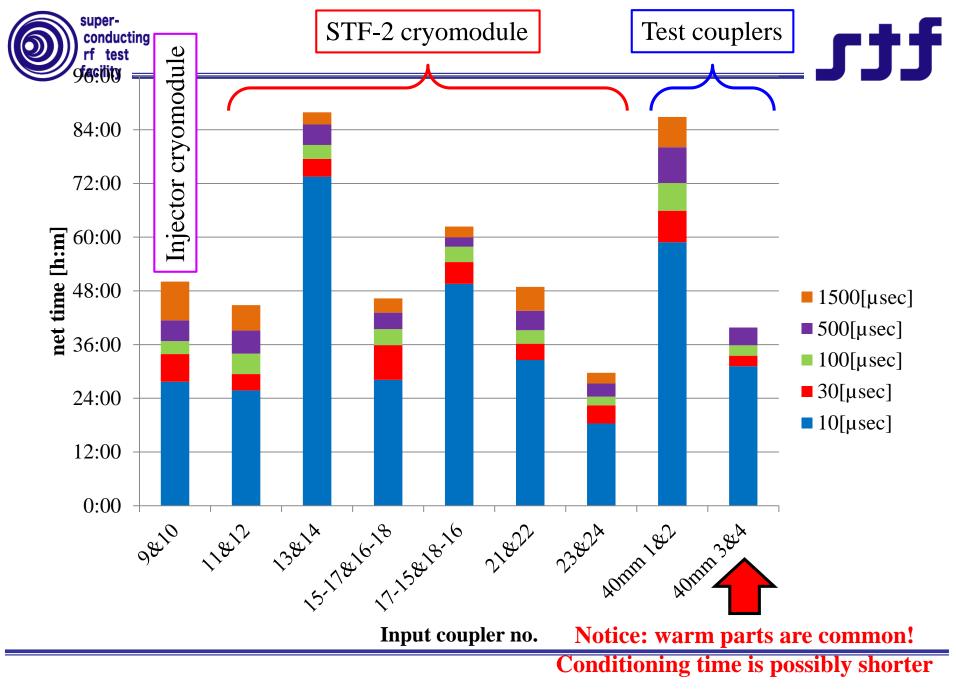


# Radiation level near Cryomodul



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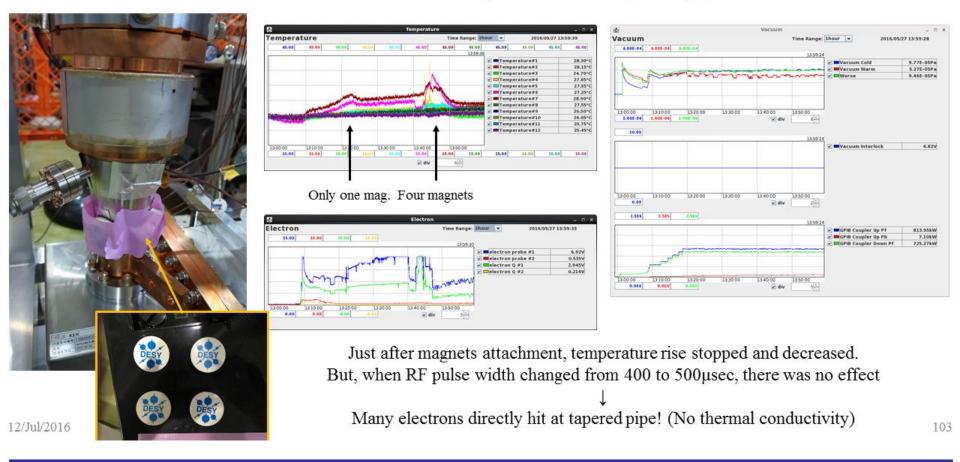






### Inspection for unusual heating by DESY magnet

I attached small DESY magnets around tapered pipe.

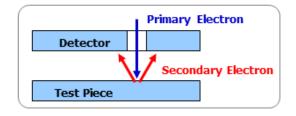




#### TTC-WG6 2014

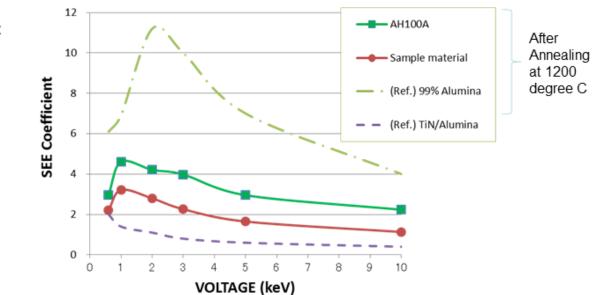
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#### SEE (Secondary Electron Emission) Coefficient Measurement Method



#### SEE Coefficient Measurement Result

- ✓ AH100A has 1/2 smaller SEE Coefficient than that of 99% alumina.
- ✓ Sample material can make SEE coefficient less than AH100A, however still higher than TiN coated alumina surface.



# Slides in TTC meeting 2014

#### TTC-WG6 2014

#### No.226KI4K28A

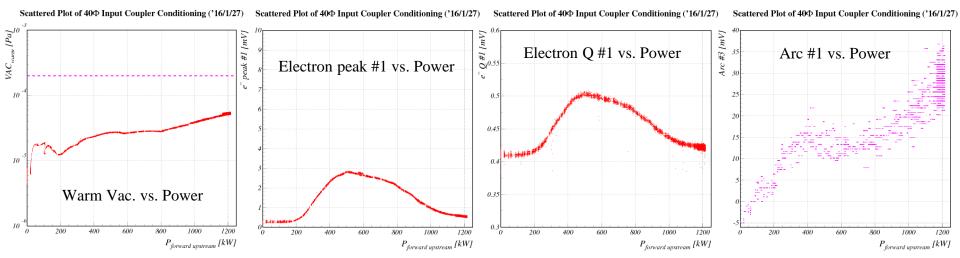
#### Comparison of Measurement Value for Evaluated Ceramic

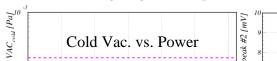
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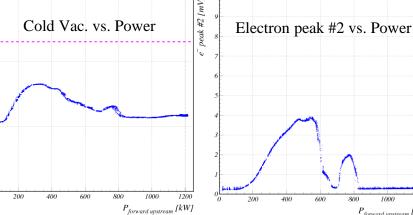
	SINEL Datas					
				99.8% Alumina for RF Application (A479B)	AH100A	Sample Material
Electrical Property	Volume Resistivity		ohm∙cm	min. 1 X 10 <sup>14</sup>	min. 1 X 10 <sup>14</sup>	-
	Surface Resistivity		ohm/□	8.9 X 10 <sup>14</sup>	7.4 X 10 <sup>15</sup>	1.2 X 10 <sup>14</sup>
	SEE Coefficient		-	11.4	4.6	3.2
	Dielectric Constant	1MHz	-	9.9	10.2	-
		8GHz	-	9.9	10.0	10.0
	Dielectric Loss Angle	s 1MHz	-	1 X 10 <sup>-4</sup> *1	1 X 10 <sup>-4</sup> *1	-
		8GHz	-	4 X 10 <sup>-5</sup>	1 X 10 <sup>-4</sup>	3 X 10 <sup>-3</sup>
Mechanical Property	Ave. Flexural Strength(RT) ASTM D2442 TYPE3		MPa	300	330	-
	Young's Modulus		GPa	370	380	-
	Poisson Ratio		-	0.23	0.25	-
Thermal Property	Thermal Conductivity (RT)		W/mK	29	24	
	Coeff. Thermal Expansion	RT- 400deg.C	ppm/K	7.0	7.4	

\*1:Lower limitation of measurement method

S-band RF Transmission Test Sample







Scattered Plot of 40Φ Input Coupler Conditioning ('16/1/27) Scattered Plot of 40Φ Input Coupler Conditioning ('16/1/27)

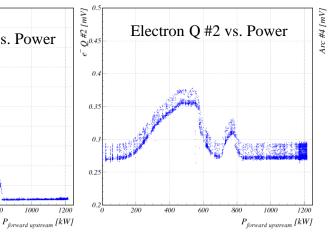
400

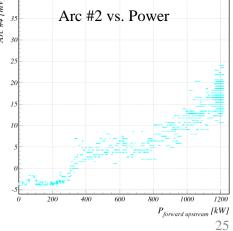
600

800

1000

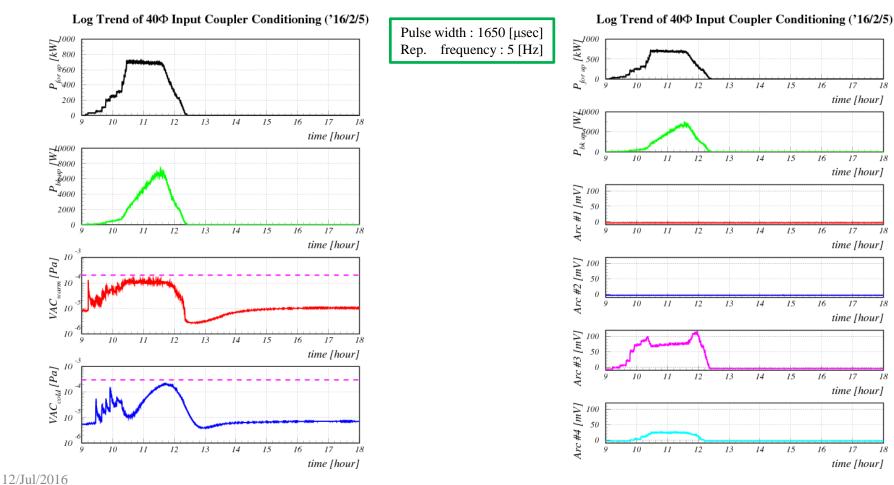
Scattered Plot of 40Φ Input Coupler Conditioning ('16/1/27) Scattered Plot of 40Φ Input Coupler Conditioning ('16/1/27)





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### One-day trend graph for coupler conditioning (normal ceramic)



time [hour]

time [hour]

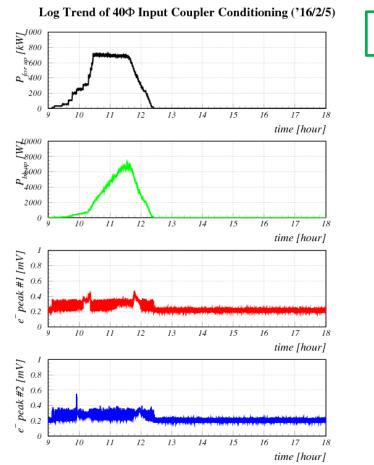
time [hour]

time [hour]

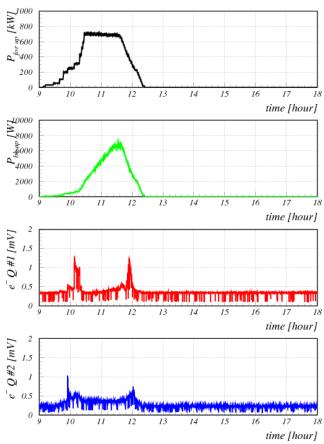
time [hour]

time [hour]

### One-day trend graph for coupler conditioning (normal ceramic)

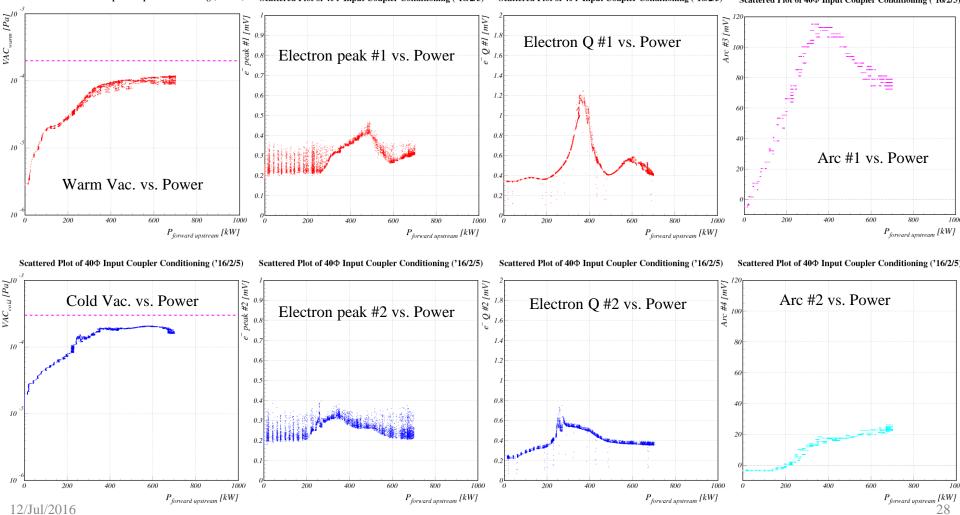


Pulse width : 1650 [µsec] Rep. frequency : 5 [Hz]



Log Trend of 40 $\Phi$  Input Coupler Conditioning ('16/2/5)

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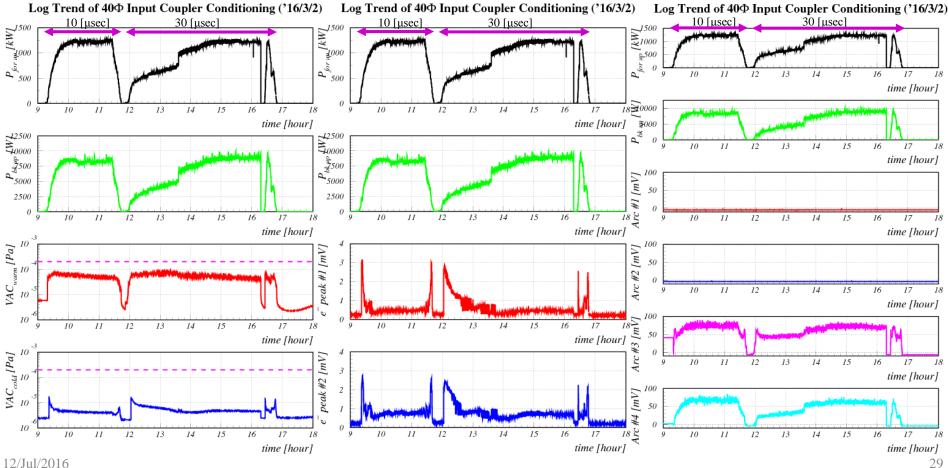


Scattered Plot of 40Φ Input Coupler Conditioning ('16/2/5) Scattered Plot of 40Φ Input Coupler Conditioning ('16/2/5)

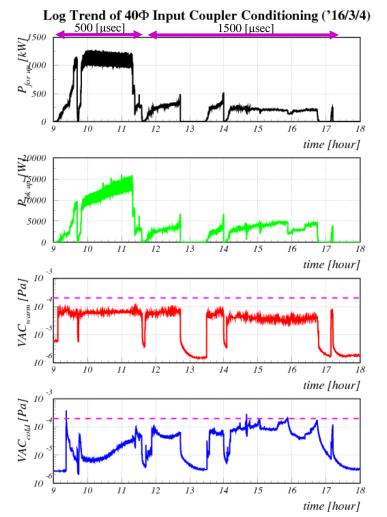
Scattered Plot of 40<sup>(16/2/5)</sup>

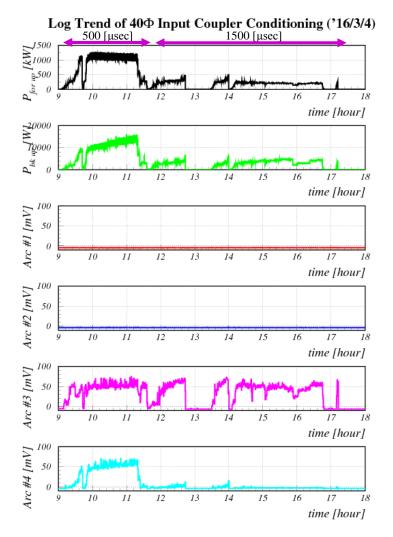
Scattered Plot of 40Φ Input Coupler Conditioning ('16/2/5)

### One-day trend graph for coupler conditioning (new ceramic)

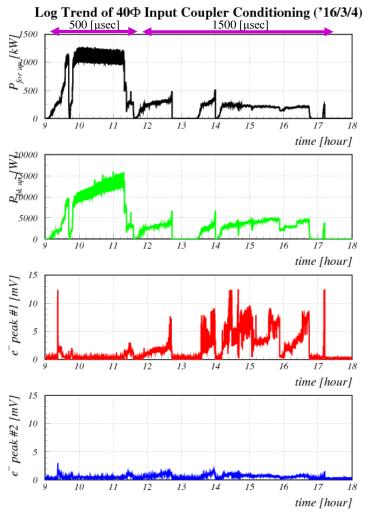


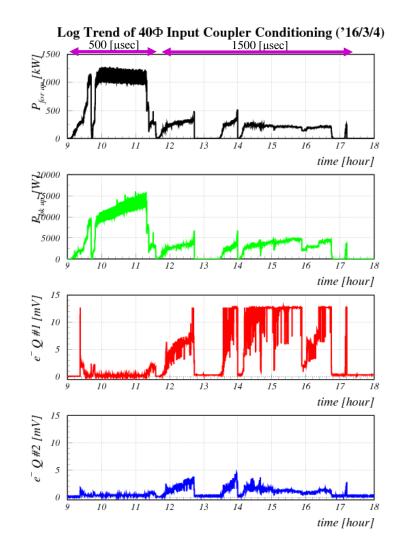
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